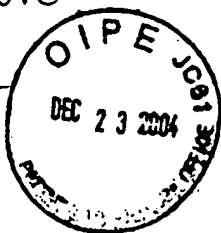


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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/072,658
Filing Date: February 7, 2002
Applicant: Tomoyuki Furuhashi et al.
Group Art Unit: 2814
Examiner: Marcos D. Pizarro-Crespo
Title: SEMICONDUCTOR DEVICE AND METHOD FOR
MANUFACTURING THE SAME
Attorney Docket: 9319S-000328

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Director of The United States Patent and Trademark Office
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT AFTER FINAL

Sir:

In response to the Office Action mailed September 30, 2004, please amend the application as follows and consider the remarks set forth below.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks begin on page 8 of this paper.